FIG. 1 (PRIOR ART)

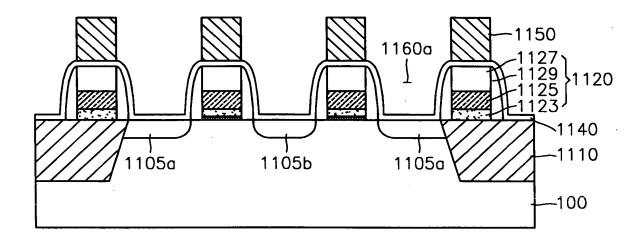


FIG. 2 (PRIOR ART)

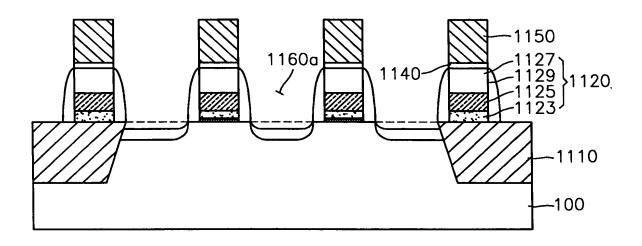


FIG. 3

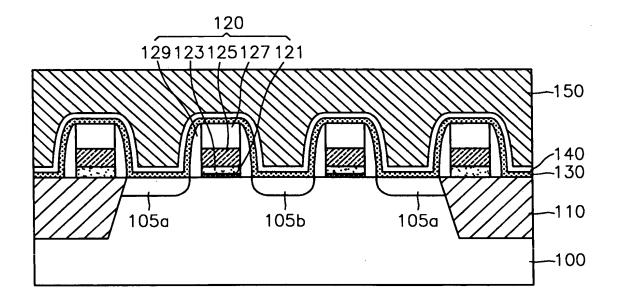


FIG. 4

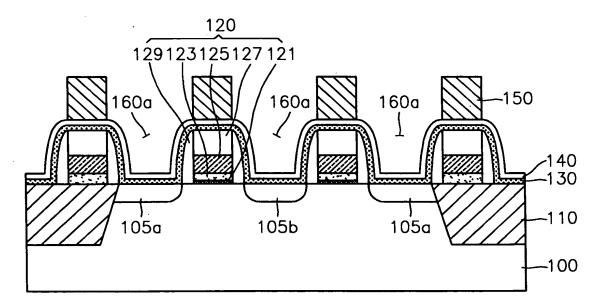


FIG. 5

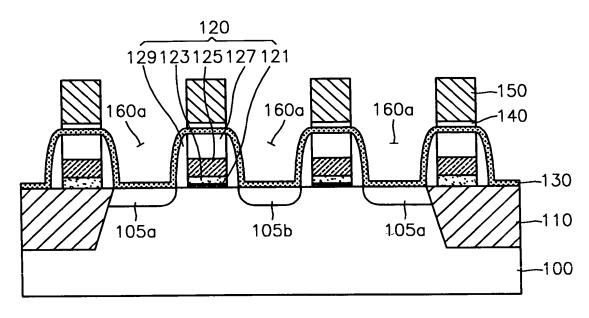
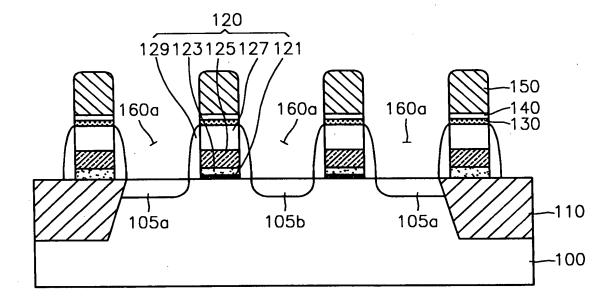


FIG. 6



"Method Of Forming A Contact In A Semiconductor Device" Appln. No. [New] – Attny. Doc. No. SEC.1063 Inventors: Yong-joon CHO et al.

FIG. 7

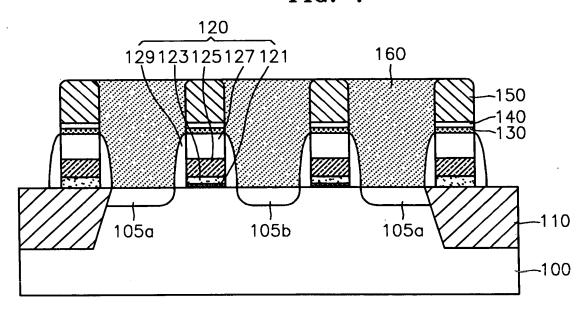


FIG. 8

